

<b>Notice of References Cited</b>	Application/Control No. 10/621,944	Applicant(s)/Patent Under Reexamination RODRIGUEZ ET AL.	
	Examiner Thu Thao Havan	Art Unit 3624	Page 1 of 1

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*	B	US-2002/0145035	10-2002	Jones, John E.	235/379
*	C	US-2002/0152164	10-2002	Dutta et al.	705/43
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**NON-PATENT DOCUMENTS**

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